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CUSTOMER NO 32,986
IP STRATEGY GROUP, P.C.
Intellectual Property Law Office
P.O. Box 700640
San Jose, CA 95170-0640

PATENT APPLICATION
ATTORNEY DOCKET NO. LMRX-P032/P1205

**IN THE
UNITED STATES PATENT & TRADEMARK OFFICE**

Applicant: Kim et al	Examiner: Vinh, Lan
Application No. 10/804,430	Group No. 1765
Filed: 3/19/2004	Confirmation No. 7228
Title: METHODS FOR THE OPTIMIZATION OF SUBSTRATE ETCHING IN A PLASMA PROCESSING SYSTEM	CERTIFICATE OF FACSIMILE TRANSMISSION I hereby certify that this correspondence is being faxed to the USPTO at 571-273-8300 on February 09, 2006. <u>11 PAGES TOTAL</u> (inclusive).
	Signed: /Alma Fazlic/ Alma Fazlic

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

Amendment A Transmittal

Transmitted herewith is an Amendment in the above-identified application in response to the Office Action mailed November 15, 2005.

The fee has been calculated as shown below.

	Claims Remaining After Amendment	Highest Previously Paid For	Present Extra	SMALL ENTITY RATE FEE		LARGE ENTITY RATE FEE
TOTAL CLAIMS	<u>35</u> -	<u>39</u>	<u>0</u>	X 25 = \$0	OR	X 50 = \$0
INDEP CLAIMS	<u>2</u> -	<u>2</u>	<u>0</u>	X 100 = \$0	OR	X200 = \$0
[] Multiple Dependent Claim Present and Fee Not Previously Paid				\$180 = \$0		\$360 = \$0
TOTAL						\$0

☒ An amendment totaling 10 pages is enclosed herewith.
☒ Please consider this communication a petition for any necessary petition and charge any additional fees required to facilitate filing the enclosed response to Deposit Account No. 50-2284 (Order No. LMRX-P032).

Respectfully submitted,
/Joseph A. Nguyen/
Joseph A. Nguyen, Esq. (Reg. No. 37,899)

Attorney Docket No. LMRX-P032/P1205

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Application No. 10/804,430

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Application No. 10/804,430	Group No. 1765
Filed: 3/19/2004	Confirmation No. 7228
Title: METHODS FOR THE OPTIMIZATION OF SUBSTRATE ETCHING IN A PLASMA PROCESSING SYSTEM	Date Sent: February 09, 2006

AMENDMENT A

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

Dear Examiner:

Please amend the above-identified application in response to the Office Action mailed
November 15, 2005 as follows:

Amendments to the Claims begin on page 2 of this paper.

Remarks/Arguments begin on page 7 of this paper.